

### **In the Specification:**

Please amend paragraph [0028] on page 12, continuing on page 13, as follows:

[0028] Next, as shown in FIG. 6, portions of the attPS layer 24 are removed in a pattern to form the clear areas 26. In the second embodiment, part of the attPS layer 24 having a thickness  $D_3$  remains over the transparent layer 22 at the clear areas 26 (see FIG. 6). Preferably, the removal of attPS layer material at the clear areas 26 is performed using a RIE process with an etch chemistry of  $\text{SF}_6$  and/or  $\text{CF}_4$ , for example. However, one of ordinary skill in the art should realize other processes that may be used for such removal, including (but not necessarily limited to) wet etching, RIE, ion milling, or any combination thereof, for example. The following equations may be used to calculate the phase shift and transmittance, and/or to determine the values of  $D_1$  and  $D_3$  that provide desired values of phase shift and transmittance, for a given wavelength ( $\lambda_t$ ) of light:

$$\Phi_t = [2(n_t-1) (D_1-D_3) / \lambda_t] 180^\circ$$

$$T_1 = [[L_1/L_o =]] A_t \exp(-4\pi k_t D_1 / \lambda_t)$$

$$T_2 = [[L_2/L_o =]] A_t \exp(-4\pi k_t D_3 / \lambda_t)$$

$$T_t = [[L_1/L_2 =]] T_1/T_2 = \exp[-4\pi k_t (D_1-D_3) / \lambda_t]$$

where:

$\Phi_t$  = phase shift of light through line-A relative to light through line-B, based on using  $D_1$  for dark area,  $D_3$  for clear area, and  $\lambda_t$ , where  $\lambda_t < \lambda_o$

$n_t$  = refractive index of attPS layer material at  $\lambda_t$

$D_1$  = attPS layer thickness on mask blank at dark area

$D_3$  = attPS layer thickness on mask blank at clear area

$\lambda_t$  = wavelength of light used

$T_t$  = transmittance through line-A ( $T_1$ ) divided by ~~relative to~~ the transmittance through line-B ( $T_2$ ), based on using  $D_1$ ,  $D_3$ , and  $\lambda_t$

$T_1$  = transmittance through line-A based on using  $D_1$  and  $\lambda_t$

$T_2$  = transmittance through line-B based on using  $D_3$  and  $\lambda_t$

$A_t$  = constant for attPS layer material at  $\lambda_t$

$k_t$  = extinction coefficient for attPS layer material at  $\lambda_t$ .